

1. This is a Request for filing a new utility PATENT APPLICATION entitled *Chemical Mechanical Polishing Endpoint Detection* without a filing fee or Oath/Declaration but for which is enclosed the following:

<u>17</u> pages of spec, claims and abstract;

31 claims, including 4 independent claims; and

3 sheets of informal drawings, Figs. 1-4

2. An Information Disclosure Statement with PTO-1449; 1 reference

3. This application is made by the following named inventors:

Inventor's Name Residence (City, State):

Sir:

Yuchun WANG San Jose, California 4409 Jan Way

Address:

San Jose, California 95124

Citizenship: People's Republic of China

mventor's Name Residence (City, State): Address:

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in in

Bernard FREY Berkeley, California 2536 Piedmont Avenue #2 Berkeley, California 94704

Citizenship: United States of America

Residence (City, State):
Address

Bulent BASOL Manhattan Beach, California

3001 Maple Avenue

Manhattan Beach, California 94116

Citizenship: United States of America

## PILLSBURY WINTHROP LLP

1600 Tysons Boulevard McLean, Virginia 22102 Tel: (650) 233-4609

Fax: (650) 233-4545 Atty/Sec: CDA/dld By: David A. Jakopin, Reg. No. 32,995

Express Mail Label: Date of Deposit:

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I certify that this paper and listed enclosures are being deposited with the U.S. Post Office "Express Mail Post Office to Addressee" under 35 CFR 1.10 on the above date, addressed to Commissioner for Patents, Box New Patent Application, Washington,

D.C. 20231

Printed Name: Kathleen M. Smith